

Notice of References Cited		Application/Control No. 10/709,718	Applicant(s)/Patent Under Reexamination LIU ET AL.	
		Examiner ERNEST UNELUS	Art Unit 2181	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0193776	10-2003	Bicknell et al.	361/685
*	B	US-2005/0089027	04-2005	Colton, John R.	370/380
*	C	US-2004/0177218	09-2004	Meehan et al.	711/114
*	D	US-2004/0083308	04-2004	Sebastian et al.	709/248
*	E	US-2004/0260873	12-2004	Watanabe, Naoki	711/114
*	F	US-6,483,107	11-2002	Rabinovitz et al.	250/239
*	G	US-6,148,349	11-2000	Chow et al.	710/33
*	H	US-6,711,632	03-2004	Chow et al.	710/29
*	I	US-2003/0061264	03-2003	Benhase et al.	709/105
J	US-				
K	US-				
L	US-				
M	US-				

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	I					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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